Do NOT Enter JSR 1/22/07

After Final Electron really Filed 1/12/07
Amendment

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Applicant(s): Hung-Eil KIM Serial No: 10/774,099

Filing Date: February 6, 2004

Title: MASK CD MEASUREMENT MONITOR OUTSIDE OF THE PELLICLE

AREA

Examiner: John S. Ruggles

Art Unit: 1756

Docket No. AMDSPH1647US

REPLY TO OFFICE ACTION DATED NOVEMBER 13, 2006

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Amendments to the Specification
Amendments to the Claims
Amendments to the Abstract
Remarks

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).